## **ELECTRONIC INFORMATION DISCLOSURE STATEMENT**

## Electronic Version v18

Stylesheet Version v18.0

Title of Invention

MAINTAINING UNIFORM CMP HARD MASK THICKNESS

Application Number:

**Confirmation Number:** 

First Named Applicant:

Attorney Docket Number:

**Shyng-Tsong Chen** 

FIS920040211US1

Art Unit:

Examiner:

Search string:

(6358839).pn

## **US Patent Documents**

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
1/2	1	6358839	2002-03-19	Li, et al.			

## **Signature**

